Comparing laser patterning of submicron structures into metal

Direct Laser Interference
- Moving metal sample
- Nano pattern possible
- Patterning on precise location possible

Direct Laser Ablation (DLA)
- Focusing lens
- Few nm
- Moving metal sample
- Low processing

Laser Induced Periodic Surface Structure (LIPSS)
- Focusing lens
- Few nm
- Moving metal sample
- Higher resolution
- Much faster processing than DLA